# PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
YU ISHII	11/30/2017
KENYA ITO	11/30/2017
KEISUKE UCHIYAMA	12/01/2017
MASAYUKI NAKANISHI	11/30/2017

## **RECEIVING PARTY DATA**

Name:	EBARA CORPORATION	
Street Address:	11-1, HANEDA ASAHI-CHO, OHTA-KU	
City:	TOKYO	
State/Country:	JAPAN	
Postal Code:	1448510	

#### **PROPERTY NUMBERS Total: 1**

Property Type	Number
Application Number:	15909758

# **CORRESPONDENCE DATA**

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ATTORNEY DOCKET NUMBER:	101716.000176	
NAME OF SUBMITTER:	MANDY XIONG	
SIGNATURE:	/Mandy Xiong/	
DATE SIGNED:	03/01/2018	
	This document serves as an Oath/Declaration (37 CFR 1.63).	

**Total Attachments: 4** 

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PATENT REEL: 045083 FRAME: 0047

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PATENT REEL: 045083 FRAME: 0048 Application No.: 15/909,758

Docket No.:

101716.000176

# COMBINED DECLARATION AND ASSIGNMENT

#### ASSIGNMENT

Assignor(s)

NAME Yu ISHII

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NAME Masayuki NAKANISHI

Address c/o Ebara Corporation, 11-1, Haneda Asahi-cho, Ohta-ku, Tokyo 1448510 Japan

WHEREAS, ASSIGNOR(S) (listed above), are inventor(s) of one or more inventions disclosed, described and/or claimed in the application referred to as Docket Number 101716,000176("the invention"), which is entitled

# POLISHING METHOD, POLISHING APPARATUS, AND SUBSTRATE PROCESSING SYSTEM

("the subject application"), and which claims priority to patent application number Japanese Patent Application No. 2017-42131 filed March 6, 2017 ("the priority application"). I authorize and direct any of the attorneys responsible for prosecuting the subject application on behalf of the ASSIGNEE to insert the application number and filing date of the subject application in the final paragraph of this assignment.

AND WHEREAS, EBARA CORPORATION, ASSIGNEE, having a place of business at 11-1, HANEDA ASAHI-CHO, OHTA-KU, TOKYO 1448510 JAPAN, is desirous of obtaining my entire right, title, and interest in, to, and under the invention:

NOW, THEREFORE, for good and valuable consideration, the receipt and sufficiency of which is hereby acknowledged, ASSIGNOR(S), hereby sell, assign, transfer, and set over, unto the ASSIGNEE, its successors, legal representatives, and assigns, the entire right, title, and interest in, to, and under the invention, and all applications for industrial property protection, including without limitation, all applications for patents, utility models, inventors' certificates, and designs that have been filed, and that may hereafter be filed, in any country, that disclose, describe, and/or claim the invention, including, without limitation, the subject application and the priority application, and all extensions, renewals, and reissues of such applications, including all divisions and continuations in whole or in part; all patents granted on such applications in any country, and all extensions, renewals, and reissues of

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COMBINED DECLARATION AND ASSIGNMENT

such patents, including all divisions and continuations in whole or in part; the right to file such applications in any country; and the right to claim for such applications in any country the priority rights derived from the priority application and the subject application under the International Convention for the Protection of Industrial Property, the Patent Laws of the United States, any other international agreement or protection, or the domestic laws of any country in which any such application is filed, as may be applicable.

AND ASSIGNOR(S) HEREBY covenant and agree that ASSIGNOR(S) have full right to convey the entire interest herein assigned, and that ASSIGNOR(S) have not executed, and will not execute, any agreement in conflict herewith.

AND ASSIGNOR(S) HEREBY further covenant and agree that ASSIGNOR(S) will communicate to the ASSIGNEE, its successors, legal representatives, and assigns, any facts known to ASSIGNOR(S) respecting the invention, and testify in any legal proceeding, sign all lawful papers, execute all disclaimers and all divisional, continuing, reissue, and foreign applications, make all rightful oaths, deliver upon request all papers, documents, affidavits, or other instruments that may be necessary or helpful in the prosecution of any application for industrial property protection describing and/or claiming the invention, and generally do everything possible to aid the ASSIGNEE, its successors, legal representatives, and assigns, to obtain and enforce proper protection for the invention in all countries.

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101716.000176

# COMBINED DECLARATION AND ASSIGNMENT

#### DECLARATION (37 CFR 1.63) FOR UTILITY OR DESIGN APPLICATION USING AN APPLICÁTION DATA SHEET (37 CFR 1.76)

Title of Invention	POLISHING METHOD, POLISHING APPARATUS, AND
	SUBSTRATE PROCESSING SYSTEM

As the below named inventor(s), I/we declare that:

This combined declaration and assignment is directed to:

the attached application	n, or
United States applicat	on or PCT international application number
filed on	•

The above-identified application was made or authorized to be made by me.

I believe that I am the original inventor or an original joint inventor of a claimed invention in the application.

I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both.

Notice to Inventor(s): A person may not execute this declaration unless that person has reviewed and understands the contents of the above-identified application, including the claims.

Notice to Inventor(s): A person may not execute this declaration unless that person is aware of the duty to disclose to the US Patent and Trademark Office all information known to the person to be material to patentability as defined in 37 CFR 1.56.

Application No.: 15/909,758 101716.000176 Docket No.:

COMBINED DECLARATION AND ASSIGNMENT

Yu ISHII	
Printed Name in English	
you Oshi	
Inventor's Signature	
30. Nov. 2017	
Date	
Karaja ITO	
Kenya ITO	
Printed Name in English	

Keisuke UCHIYAMA Printed Name in English

Inventor's Signature

D1. Dec. 2017

Masayuki NAKANISHI Printed Name in English

Inventor's Signature

30. Nov. 20/7
Date

The foregoing Combined Declaration and Assignment covers patent application number  $\frac{15/909,75}{8}$  filed on March 01, 2018.

/Michael J. Swope/

Name of Attorney: Michael J. Swope

38,041 Registration No.: Date of Insertion:

March 01, 2018

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**RECORDED: 03/01/2018**